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CENTRAL INTELLIGENCE AGENCY

NO. 1779 P. 1

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Docket No. 0819-1052

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yoshihisa NAGANO et al.

Serial No.10/829,476

Filed: April 22, 2004

For: *Semiconductor Device and Method of  
Fabricating the Same*

)

) Group Art Unit:2826

) Examiner: Not Yet Assigned

)

) Date: December 15, 2004

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Name: Eddie


STATUS INQUIRY

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please advise, in writing, as to the current status of the above-identified application.

Respectfully submitted,

  
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